

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Takeshi HIKATA
Title: METHOD OF PRODUCING
CARBON NANOSTRUCTURE
Appl. No.: 10/591,740
International Filing Date: 5/19/2005
371(c) Date: 9/6/06
Examiner: Roberts P. Culbert
Art Unit: 1792
Confirmation Number: 3133

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated March 31, 2009, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows: